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**PATENT**

5589-11400/P1618

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:  
Dardzinski**

Serial No. 10/723,585

Filed: November 26, 2003

**For: METHOD AND APPARATUS FOR  
INSPECTING A SEMICONDUCTOR  
WAFER**

Group Art Unit: 2877  
Examiner: Nguyen, Sang H.

Atty. Dkt. No. 5589-11400

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: MS: Non-Fee Amendment Commissioner for Patents, P.O. Box 1450, Alexandria, VA, 22313-1450 on the date indicated below:

3-1-06

Data

Carmela Bento

Pamela Gerik

**AMENDMENT; RESPONSE TO OFFICE ACTION MAILED DECEMBER 1, 2005**

**MS: Non-Fee Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed December 1, 2005 to further highlight reasons why the application is in condition for allowance.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks begin on page 6 of this paper.**